

Attorney's Docket No.: 07977-093002
Client's Ref. No.: US3164D1

OFFICIAL COMMUNICATION**FACSIMILE****FOR THE PERSONAL ATTENTION OF:****EXAMINER EUGENE LEE****GROUP 2815 FAX NO: (703) 872-9319****FAX RECEIVED**

Number of pages including this page 8

APR 15 2003

TECHNOLOGY CENTER 2800

Applicant : Hisashi Ohtani, et al.

Art Unit : 2815

Serial No. : 09/379,702

Examiner : Eugene Lee

Filed : August 24, 1999

Confirmation No.: 1613

Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICES

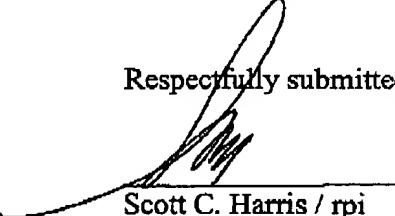
FACSIMILE COMMUNICATION

Commissioner for Patents
Washington, D.C. 20231

Sir:

Attached to this facsimile communication cover sheet is a Response to Final Office Action, faxed this 17th day of March, 2003, to Group 2815, the United States Patent and Trademark Office.

Respectfully submitted,


Scott C. Harris / rpi
Reg. No. 32,030

Date: March 17, 2003

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Box Final

Commissioner for Patents
Washington, D.C. 20231

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RESPONSE

In response to the official action mailed 10/16/02, paper
no. 20 in the above referenced case, please amend the
application as follows:

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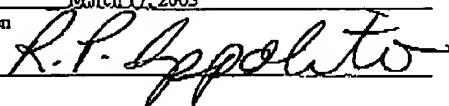
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